

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Ohnuma, et al.

Art Unit : 1765

Serial No.: 09/050,182

Examiner : R. Kunemund

Filed : March 26, 1998

Title : METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE

Commissioner for Patents
Washington, D.C. 20231RESPONSE

This is in response to the action mailed November 01, 2000.

REMARKS

Reconsideration and allowance of the above-referenced application are respectfully requested.

Claims 1-59 and 76-81 were rejected under the judicially created doctrine of obviousness-type double patenting as being allegedly unpatentable over claims 1-31 of U.S. Patent 5,700,333 to Yamazaki et al. Claims 1-16 and 76-77 were rejected under 35 U.S.C. 103(a) as being allegedly unpatentable over Yamazaki et al., and claims 17-59, 75, and 78-81 were rejected under 35 U.S.C. 103(a) as being allegedly unpatentable over Yamazaki et al. in view of Zhang et al. (U.S. 5,569,936).

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